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Express Mail No. EV758929076US

Attorney Docket No. 108298404US2
Disclosure No. 99-0319.02/US

AMENDMENT TRANSMITTAL LETTER

Docket No.
108298404US2

Application No. 10/772,541-Conf. #8900	Filing Date February 5, 2004	Examiner Y. T. Tadesse	Art Unit 1734
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Applicant(s): Agarwal et al.

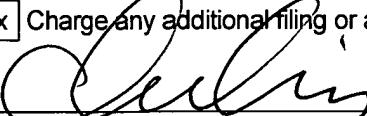
Invention: APPARATUS FOR FORMING A PLANARIZING PAD FOR PLANARIZATION OF
MICROELECTRONIC SUBSTRATES

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	15	- 20 =	0	x	
Independent Claims	6	- 4 =	2	x 200.00	400.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					400.00

 Large Entity Small Entity No additional fee is required for this amendment. Please charge Deposit Account No. 50-0665 in the amount of \$.
A duplicate copy of this sheet is enclosed. A check in the amount of \$ 400.00 to cover the filing fee is enclosed. Payment by credit card. Form PTO-2038 is attached. The Director is hereby authorized to charge and credit Deposit Account No. 50-0665
as described below. A duplicate copy of this sheet is enclosed. Credit any overpayment. Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.
Chen Liang

Attorney/Agent Reg. No.: 51,945

Dated: February 28, 2006

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RESPONSE UNDER 37 C.F.R. § 1.116

EXPEDITED PROCEDURE – Art Unit 1734

Attorney Docket No. 108298404US2

Disclosure No. 99-0319.02/US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: VISHNU K. AGARWAL AND
DINESH CHOPRA

APPLICATION No.: 10/772,541

FILED: FEBRUARY 5, 2004

FOR: APPARATUSES FOR FORMING A
PLANARIZING PAD FOR
PLANARIZATION OF
MICROELECTRONIC SUBSTRATES

EXAMINER: YEWEBDAR T.
TADESSE

ART UNIT: 1734

CONF. NO: 8900

Amendment Under 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated November 29, 2005 in the above-identified application. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.

03/02/2006 DEMMANU1 00000017 10772541

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